

IFW
PatentAttorney Docket No. 1018765-000171

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Masafumi MIYAKAWA et al.

Application No.: 10/507,245

Filing Date: September 10, 2004

Title: PRESSURE-SENSITIVE ADHESIVE FILM FOR THE SURFACE PROTECTION OF SEMICONDUCTOR WAFERS AND METHOD FOR PROTECTION OF SEMICONDUCTOR WAFERS WITH THE FILM

Group Art Unit: 1711

Examiner: JEFFREY C MULLIS

Confirmation No.: 9077

THIRD
INFORMATION DISCLOSURE STATEMENT
TRANSMITTAL LETTERCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a THIRD Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☒ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of _____ is enclosed for the fee due.
- ☐ Charge _____ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BUCHANAN INGERSOLL PC

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By

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Date: February 15, 2006**Buchanan Ingersoll PC**
ATTORNEYS

Including attorneys from Burns Doane Swecker & Mathis

(8/05)



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METHOD FOR PROTECTION OF SEMI-)	
CONDUCTOR WAFERS WITH THE FILM)	

THIRD INFORMATION DISCLOSURE STATEMENT

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Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, applicants hereby submit an Office Action dated November 25, 2005 in the corresponding Singapore application in conformance with the provisions of 37 C.F.R. §§ 1.97 and 1.98. All the documents cited in the Singapore Action have been previously provided in the Information Disclosure Statement filed on May 27, 2005, and additional copies will not be provided here. It is noted that U.S. Patent No. 5,955,512 corresponds to the cited GB patent document.

CERTIFICATION UNDER 37 C.F.R. §1.97(e)

I, the undersigned, hereby certify that the Singapore Office Action was first issued in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

BUCHANAN INGERSOLL PC

Date February 15, 2006

By: Robert G. Mukai
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